

RECEIVED
CENTRAL FAX CENTER

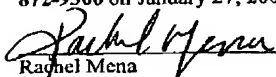
JAN 27 2004

001

OFFICIAL

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being transmitted by facsimile to the Commissioner for Patents, ATTN: LIE 2851 at fax number 703-872-9306 on January 27, 2004.

TOTAL PAGES: 5
Rachel Mena1/27/04
Date

Practitioner's Docket No. 40620-0002 US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Thomas D. Stahl et al.)
Serial No.: 10/693,329) Group No.: 2851
Filed: October 23, 2003) Examiner: Not assigned
For: Method and Apparatus for a Projection System)
System)

ATTN: LIE 2851
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

COMMUNICATION

Enclosed is a *revised* Request for Withdrawal as Attorney or Agent and Change of Correspondence Address (PTO/SB/83), noting the correct correspondence address for Thomas D. Stahl, and listing the company name, Digital Cinema Engines Inc.

For background purposes, Applicant mailed a Request for Withdrawal as Attorney or Agent and Change of Correspondence Address (PTO/SB/83) to the U.S. Patent and Trademark Office on January 8, 2004, including a copy of a transfer letter to Thomas D. Stahl. The Request had the incorrect correspondence address and did not include the company's name.

This communication, including the amended request, and transfer letter to Digital Cinema Engines Inc. should be considered and entered to reflect the amended address and the company's name.

Attorney Docket No.: 40620-0002
Application No. 10/693,329
C:\NrPortb\SiliconValley\RMENA\2002439_1.DOC

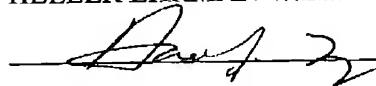
COMMUNICATION - PAGE 1 -

The Commissioner is authorized to charge any additional fees which may be required, including petition fees and extension of time fees, to Deposit Account No. 08-1641 (Docket No. 40620-0002).

Respectfully submitted,

HELLER EHRMAN WHITE & MCAULIFFE LLP

Date: Jan. 27, 2004



Hao Y. Tung, Reg. No. 43,209

275 Middlefield Road
Menlo Park, CA 94025
(650) 324-7000
Customer No. 25213

Attorney Docket No.: 40620-0002
Application No. 10/693,329
C:\N\Portbl\SiliconValley\RMENA\2002439_1.DOC

COMMUNICATION - PAGE 2 -